

04/12/01  
jc839 U.S. PTO

04-16-01

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Docket No. 005651/ETCH/CHMBR/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application  
Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Re: Inventor(s): Michael BARNES and David Palagashvili  
Title: PLASMA REACTOR ELECTRODE

jc921 U.S. PTO  
09/834343  
04/12/01

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 9 pages.  
☒ Drawings totaling 2 pages, ☒ Formal ☐ Informal.  
☒ Executed Declaration and Power of Attorney.  
☒ Assignment of the invention to **Applied Materials, Inc.**  
☒ Assignment Recordation Cover Sheet  
☒ Information Disclosure Statement (37 CFR 1.98)

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	16	-20=	0	X\$18.00	\$000.00
Independent Claims	2	-3=	0	X\$80.00	\$000.00
Basic Filing Fee				\$710.00	\$710.00
TOTAL FEES					\$710.00

- ☒ The Commissioner is hereby authorized to charge \$710.00 to Deposit Account No. 50-1074.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. **50-1074**. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:

**PATENT COUNSEL  
APPLIED MATERIALS, INC.  
Legal Affairs Department  
P.O. BOX 450A  
Santa Clara, CA. 95052**

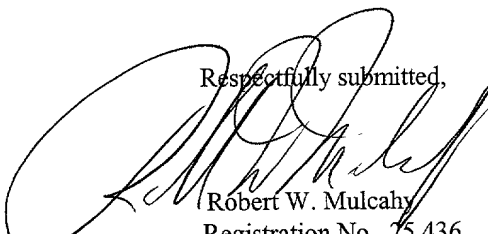
I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D C 20231

Express Mail Receipt No EL66180502545

Date of Deposit 4-12-2001

Signature Beit Mulcahy

Respectfully submitted,

  
Robert W. Mulcahy  
Registration No. 25,436